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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10053160	01 15 2002	438		1765	Vinh

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**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED: YES LV

TAIWAN 90127509 11/06/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
Verified and Acknowledged Examiner's Initials			B-4453 619445-9
TITLE : Method of etching a mask layer and a protecting layer for metal contact windows			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED		
Assistant Examiner		DRAWING		
Amount Due	Date Paid	Sheets Drawn.	Fig.s Drawn.	Print Fig.
Primary Examiner				

TERMINAL

DISCLAIMER

PREPARED FOR ISSUE

APPLICATION NUMBER

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